

PTO-1449

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09/866,205Applicant(s)
Shea Chen, et al.Information Disclosure Citation
in an ApplicationDocket Number
004578.1123Group Art Unit
3726Filing Date
05/25/2001

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	5,652,559	07/29/97	Saia, et al.	—	—	
B	6,100,477	08/08/2000	Randall, et al.	200	181	
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
P	0 709 911 A2	05/01/96	EPC	—	—	N/A	
Q							
R							

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
S	Chan, et al., "Comprehensive Static Characterization of Vertical Electrostatically Actuated Polysilicon Beams", 1999 IEEE Design & Test of Computers, October-December 1999, pp. 58-65.	
T		

EXAMINER

Renee Luebke

DATE CONSIDERED

5/15/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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